

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Isamu Kobori et al.	Art Unit :	2812
Serial No. :	10/623,581	Examiner :	Stanetta Isaac
Filed :	July 22, 2003	Conf. No. :	6534
Title :	METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR		

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 31, 2007

Please amend the above-identified application as follows: